



AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROSECUTION - GROUP ART UNIT 2874

3500.013974

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
: Examiner: Davienne Monbleau
TADAHIRO OHMI ET AL.)
: Group Art Unit: 2874
Application No.: 09/425,015)
: Filed: October 25, 1999)
: For: GAS SUPPLY PATH)
STRUCTURE FOR A GAS LASER :
METHOD, LASER) October 16, 2002

Commissioner for Patents
Box: AF
Washington, D.C. 20231

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Office Action dated July 16, 2002, please amend
the above-identified application as follows and consider the following remarks.

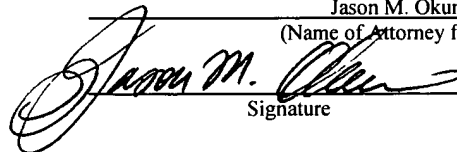
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October 16, 2002

(Date of Deposit)

Jason M. Okun

(Name of Attorney for Applicants)



Signature

October 16, 2002

Date of Signature

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